

CPSHR1 - CRYO POSITIONING STAGE HIGH RESONANCE 1



Features

- xyz motion for very stable cavity measurements
- Parallel kinematics for optimized stiffness
- High resonance frequencies
- Coarse motion using Cryo Linear Actuators
- Scanning motion integrated
- 20mK to 375K, vacuum compatible
- Compatible with CVIP1 vibration isolator

Description / Applications

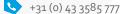
The Cryo Positioning Stage High Resonance (CPSHR) is a XYZ positioning stage developed for operation in a cryo-vacuum environment, especially suited for very stable cavity measurements. Parallel kinematics result in a light and stiff stage with very high internal resonance frequencies, making it less sensitive to floor vibrations. The CPSHR 1 is the most compact design with small stroke and highest resonances.

Specifications

Specifications	
General info	
Type of motion	xyz with parasitic angular motion
Parasitic angle from xy stroke	20 mrad/mm, about the x and y axis
No load resonance frequency	xy: 1,5 kHz / z: 4,0 kHz
Dimensions	See drawings below
Operational environmental conditions	20 mK to 375 K, ambient to UHV
Weight	300 g
Stepping motion	
Travel range	x ±1,3 mm / y ±1,5 mm / z ±0,5 mm (not simultaneously)
Actuator	CLA2201, see drawings for calculating actuator outputs to system motion
Minimal step size @ 300 K	5 nm
Minimal step size @ 4 K	1 nm
Scanning motion	
Actuator	Piezo actuators, see drawings for calculating piezo outputs to system motion
Scanning range @ 300 K, typical	x 6,5 μm / y 7,5 μm / z 2,5 μm (not simultaneously)
Scanning range @ 4 K, typical	x ±1,3 μm / y ±1,5 μm / z ±0,5 μm (not simultaneously)
Minimal step size	Sub-nm
Drive voltage @ 300 K	-30 V to 120 V
Drive voltage @ 4 K	-150 V to 150 V
Forces and load capacity	
Load capacity	200 g
Materials	
Main body	Titanium
CLA2201	Stainless steel, ceramic, piezo actuator*
Scanner	Piezo actuator*
*Piezo actuator	Low voltage multilayer, ceramic insulated
Model specific information	
-S	xyz scanner added, see above for range
Electronics CPSC	
Controller Base Cabinet	CAB
Driver for stepping and scanning	CADM or PSM (scanning only)











Ordering Information

Available models

CPSHR₁-S Cryo Positioning Stage High Resonance 1-Scanner

Available Options

-HV Upgrade to High Vacuum compatibility -UHV Upgrade to Ultra High Vacuum compatibility

Accessories

Accessory Kit Mechanical 1 AKM₁ AKE₁ Accessory Kit Electrical 1

Mechanical and electrical information

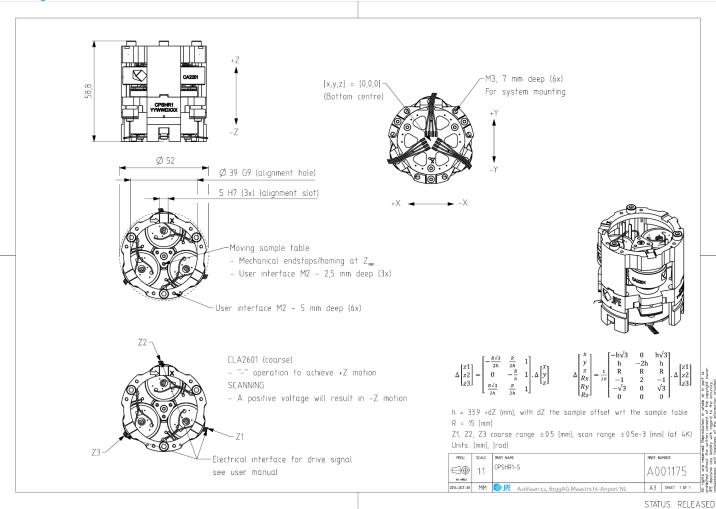
https://www.jpe-innovations.com/cryo-nano-products/

Download 3D step files and manuals from:

For quotations, specials, or engineering services, please contact us at:

https://www.jpe-innovations.com/contact/

Drawings



Contact





